Negative refractive index in coaxial plasmon waveguides

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Abstract: We theoretically show that coaxial waveguides composed of a metallic core, surrounded by a dielectric cylinder and clad by a metal outer layer exhibit negative refractive index modes over a broad spectral range in the visible. For narrow dielectric gaps (10 nm GaP embedded in Ag) a figure-of-merit of 18 can be achieved at $\lambda_0 = 460$ nm. For larger dielectric gaps the negative index spectral range extends well below the surface plasmon resonance frequency. By fine-tuning the coaxial geometry the special case of $n = -1$ at a figure-of-merit of 5, or $n = 0$ for a decay length of 500 nm can be achieved.

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OCIS codes: (240.6680) Optics at surfaces; (160.3918) Metamaterials; (222.0220) Optical design and fabrication.

References and links

1. Introduction

Controlling the propagation of light at the nanoscale is one of the challenges in photonics. Surface plasmons, electromagnetic modes that propagate at a metal/dielectric interface provide a key opportunity to achieve this goal, due to their relatively small evanescent fields [1, 2]. Moreover, as their dispersion can be strongly controlled by geometry, their effective wavelength can be shrunken well below the free-space wavelength, enabling further miniaturization of optical components. Initial experiments on plasmon optics were carried out at planar metal/dielectric interfaces, demonstrating basic control of plasmons. Plasmonic components such as mirrors [3, 4] and waveguides [5, 6] were realized, however still of relatively large size due to the > 100 nm evanescent tails, and with limited control over dispersion. Subsequently, insulator-metal-insulator structures were investigated, and have demonstrated confinement of light to < 100 nm length scales in taper geometries [7, 8], though at high loss. The reverse, metal-insulator-metal (MIM) geometries, have demonstrated lower loss, higher dispersion [9, 10], and recently the attainment of a negative index of refraction [11–13].

A disadvantage of planar MIM structures is that they only confine light in one transverse direction. Recently, coaxial MIM waveguides, composed of a metal core surrounded by a dielectric cylinder clad by a metal outer layer have been introduced, that confine light in all transverse directions [14, 15]. We have recently reported optical transmission measurements through single coaxial waveguides, from which the dispersion diagram for these nanoscale waveguides was determined [16].

Inspired by the earlier work on MIM waveguides, a natural question arises whether coaxial waveguides would possess a negative refractive index, and if so, for what geometry and over what spectral range. Since the coaxial waveguides are essentially 3-dimensional objects, the observation of negative index in individual coaxes, also inspires the design of 3-dimensional negative-index metamaterials [17–21] composed of arrays of coaxial waveguides [22].

Here, we theoretically study the dispersion of coaxial Ag/Si/Ag plasmon waveguides and demonstrate that for well-chosen geometries modes with a negative refractive index are ob-
served. These modes are dominant over other waveguide modes for a wide range of frequencies above the surface plasmon resonance frequency. We discuss the influence of waveguide geometry and material on the mode index and demonstrate that the figure-of-merit (FOM), defined as the magnitude of the real part of the propagation constant in the waveguide divided by the imaginary part [13, 23], can be as high as 18.

2. Method

The azimuthal dependence of the fields is described by the harmonic function $e^{in\phi}$ of order $n$. In the remainder we only consider modes with $n = 1$, since these are the lowest order modes that couple to free-space radiation. The radial dependence of the fields in all three domains (metal–dielectric–metal) is described by solutions to the 2nd order Bessel differential equation. We apply a Bessel function of the first kind, $J_n$, to the metal core, as that function remains finite at the waveguide axis. A Hankel function of the first kind, $H_n^{(1)}$, is applied to the metal cladding. Inside the dielectric channel the radial field is described by two linearly independent cylinder functions. The arguments of the cylinder functions in each of the three domains is $\kappa_ir$, where $\kappa_i$ is the radial wave number in medium $i$, defined via

$$\kappa_i^2 \equiv \varepsilon_i \frac{\omega^2}{c^2} - k^2$$

where $\varepsilon_i$ is the complex dielectric constant in domain $i$. To satisfy the condition that fields decay to zero at radial infinity we take the square root of Eq. (1) such that the radial wave number has a positive imaginary part.

On each domain boundary we formulate four continuity conditions for the tangential components of the electric and magnetic fields. The optical eigenmodes of the coaxial waveguide are found when the determinant of the resulting homogeneous system of eight equations with eight unknown coefficients vanishes,

$$\det[M(k)] = 0$$

Fig. 1. Coaxial plasmon waveguide geometry and numerical mode solving method. (a) Schematic cross-section of a coaxial waveguide with the definition of the cylindrical polar coordinates, $r$, $\phi$, and $z$. The metallic inner core and outer cladding separate a dielectric channel. A schematic wave propagating in the waveguide in the direction of positive $z$ is also indicated. (b) Argument $\theta$ of the determinant, $\det[M(k)]$, plotted in the complex $k$-plane for a Ag/Si/Ag waveguide with 75 nm inner core diameter and 10-nm-wide dielectric channel at $\omega = 3 \times 10^{15}$ rad/s. By cycling around the closed loop indicated by the dashed square the net number of discontinuities in $\theta$ is determined. Zero positions are indicated by the white circles.
where \( M \) is the matrix of the system of equations. We have used two independent methods for determining the optical modes, \( k(\omega) \), of the structure. One involved a numerical procedure developed to detect local minima of the determinant of the system in the complex \( k \)-plane. The other method relies on the fact that the argument, \( \theta \), given by

\[
\text{det}[M(k)] = |\text{det}[M(k)]|e^{i\theta}
\]

is undefined when \( \text{det}[M(k)] = 0 \). This can be visualized in a plot of \( \theta \) in the complex \( k \)-plane. An example is shown in Fig. 1(b) where \( \theta \) is plotted for a coaxial waveguide with a Ag core and cladding and a 10 nm silicon spacer layer. We used empirically determined optical constants for the metal [24] and dielectric [25]. Contour lines in the figure appear to close in on each other at each of the zeros, which are indicated by the white dots in the figure. By counting each discontinuity \(-\pi \to \pi \) and \(\pi \to -\pi \) about a closed loop in the figure [for an example, see the dashed square loop in Fig. 1(b)] we are able to determine the number of zeros in the enclosed area. In case we find that one or more zeros reside in the area, we split the area up in smaller pieces and repeat the procedure until the location of the zero(s) is determined with double computer precision.

Using this method, solutions for \( k \) were found for real frequency, so that dispersion relations, \( \omega(k) \), could be constructed. Calculations were performed in the optical angular frequency regime \( 1 \times 10^{15} \text{ rad/s} < \omega < 5 \times 10^{15} \text{ rad/s} \) (free-space wavelength, \( \lambda_0 = 377–1884 \text{ nm} \)). We only consider modes with positive energy velocity, \( v_e \), or equivalently, positive attenuation constant \( k'' \) [13]. Therefore, to achieve antiparallel energy and phase velocity, which is the unique
requirement for a negative mode index, the propagation constant $k'$ needs to be negative.

3. Results

Figure 2 shows the dispersion relation, $\omega(k)$, for the three lowest-order modes in a coaxial waveguide consisting of a 75-nm-diameter Ag core surrounded by a 25-nm-thick Si layer and infinite Ag cladding. In (a) the angular frequency is plotted against $k'$, while (b) shows the frequency as function of $k''$, which determines the propagation length of light in the waveguide via

$$L = \frac{1}{2k''}.$$  (4)

The surface plasmon resonance frequency $\omega_{SP} = 3.15 \times 10^{15}$ rad/s ($\lambda_0 = 598$ nm) is indicated by the horizontal line.

Figure 2(a) shows two coaxial modes (blue dashed line and green dotted line) with positive propagation constants over the entire spectral range. Both dispersion curves closely resemble the dispersion of a surface plasmon polariton propagating along a planar Si/Ag interface. However, the corresponding propagation constants [Fig. 2(a)], are nearly three times as large as for the planar single interface plasmon. This is due to the fact that confinement of the plasmon in the coaxial waveguide geometry leads to larger mode overlap with the metal. Figure 2(a) also shows the existence of a third mode (red drawn curve) that has a negative propagation constant $k'$ for frequencies below $3.8 \times 10^{15}$ rad/s ($\lambda_0 = 496$ nm). The effective index $n = c k' / \omega$ ranges from $-9 < n < 5$ in the frequency range of Fig. 2. The insets in (a) show the $H_y$ field in the transverse plane for the negative-index mode (calculated at $\omega = 3.6 \times 10^{15}$ rad/s) as well as for the most dispersive positive mode (blue dashed curve in Fig. 2(a), $\omega = 2.8 \times 10^{15}$ rad/s). From the images it is clear that the mode with positive effective index has a symmetric field distribution with respect to the two centers of the dielectric channel on the x-axis. The $H_y$ field is primarily...
Fig. 4. Dispersion relations for coaxial waveguides with Ag core and cladding and 70-nm-wide Si dielectric channel, (a): $\omega(k')$; (b): $\omega(k'')$. The inner core diameter, $d_{\text{core}}$, is 45 nm (blue curves), 75 nm (green curves) and 100 nm (red curves). Only modes with negative index are plotted. Bold lines indicate the spectral range where the mode is dominant over the positive-index mode.

concentrated at the boundary between the metal core and dielectric channel. The negative-index mode in contrast, has its field primarily concentrated at the outermost channel boundary and has an $H_y$-field distribution that is anti-symmetric about the center of the dielectric channel, similar to modes with negative index in planar metal-insulator-metal waveguides [13].

Figure 2(b) shows that for frequencies below the surface plasmon resonance frequency $\omega_{\text{SP}}$ the lowest-order positive-index mode (blue dashed line) has lowest loss and will therefore be dominant over other modes. Interestingly, above $\omega_{\text{SP}}$ the negative-index mode (red curve) becomes the dominant mode, as its losses are significantly lower than those for the positive-index modes. Figure 2(c) shows the figure-of-merit (FOM), $k'/k''$, of the modes. As can be seen, the negative-index mode has a FOM that approaches 10 for a narrow frequency interval around $3.4 \times 10^{15}$ rad/s ($\lambda_0 = 554$ nm). The data in Fig. 2 clearly demonstrate that dominant modes of negative index indeed exist in coaxial plasmon waveguides.

Next, we investigate the conditions that are required to achieve a negative index by varying the geometry and materials of the waveguide. Figure 3 shows the effect of changing the dielectric layer thickness on the dispersion of the negative index mode. Calculations were performed for a Ag/Si/Ag coaxial waveguide with a core diameter of 75 nm for a dielectric layer thickness of 10 nm, 30 nm, and 70 nm. Figure 3(a) shows that the variation in dielectric layer thickness has a very dramatic effect on the dispersion of the negative-index mode. First of all, the largest negative index is observed for the thinnest dielectric. Second, while for the 10-nm and 30-nm dielectric gaps the frequency of the resonance associated with the negative index mode appears close to the surface plasmon resonance at $3.2 \times 10^{15}$ rad/s, for the 70-nm gap this resonance is significantly red-shifted to $2.5 \times 10^{15}$ rad/s. The spectral range over which the mode is dominant, indicated by the bold curves in Fig. 3(a), also extends to lower frequencies when increasing the channel width. For the 70-nm gap a narrow frequency range is found near $2.4 \times 10^{15}$ rad/s ($\lambda_0 = 785$ nm) where the index is negative and the figure-of-merit is 5.

As the dispersion branches cross the $k' = 0$ line the effective refractive index of the mode vanishes [26]. Coaxial waveguides with a narrow dielectric gap suffer high loss at this frequency. The green star in Fig. 3(b) indicates the frequency at which the dispersion curve crosses the
Fig. 5. Dispersion relations for coaxial waveguides with 75-nm-diameter metal core, 25-nm-wide dielectric channel and infinite metal cladding, (a): $\omega(k')$; (b): FOM $k'/k''$. The type of metal in the core and cladding, as well as the dielectric material was varied. The frequency axes are normalized to the corresponding surface plasmon resonance frequency $\omega_{SP}$. Blue curves are for a Si channel surrounded by Ag ($\omega_{SP} = 3.15 \times 10^{15}$ rad/s), green curves for GaP in Ag ($\omega_{SP} = 3.49 \times 10^{15}$ rad/s), red curves for SiO$_2$ in Ag ($\omega_{SP} = 5.24 \times 10^{15}$ rad/s) and purple curves for Si in Au ($\omega_{SP} = 2.77 \times 10^{15}$ rad/s). Bold curves indicate the spectral range where the negative-index mode is dominant.

$k' = 0$ line for the 30-nm gap; a high value of $k'' = 10^7$ m$^{-1}$ is found. In contrast, for the 70-nm-wide dielectric channel waveguides the losses at the $k' = 0$ crossing [red star in Fig. 3(b)] are much lower ($k'' < 10^6$ m$^{-1}$), corresponding to a decay length of 500 nm. Note that in the spectral range where the phase velocity $\omega/k'$ goes to zero, the group velocity, $v_g = d\omega/dk'$, is much larger than zero.

The two striking effects observed here: a) waveguide resonances that shift with geometry, and b) increased propagation length for $k' = 0$ modes for increasing dielectric thickness are in strong contrast to what is observed in planar metal-insulator-metal waveguides [13]. This suggests that coupling of plasmon fields across the nanoscale diameter of the metal core strongly influences the dispersion of the negative index modes. To investigate this, we studied the influence of the metal core diameter on the dispersion of the mode, while keeping the channel width fixed to 70 nm. Figure 4 shows the results for waveguides with inner core diameters of 45, 75 and 100 nm. The figure shows that the spectral range where the mode is both dominant and characterized by a negative index becomes smaller going from a 45-nm-diameter core to a 75 nm core, and vanishes when the core size is increased to 100 nm. This behavior coincides with a red-shift of the resonance in $k''$ when the core diameter is increased [Fig. 4(b)]. We attribute the resonance red-shift for increasing core diameter to a depolarization effect similar to what is known for bulk metallic particles, which show a plasmon resonance red-shift for increasing diameter [27]. Based on this insight, we predict that a large degree of control over dispersion and resonance red-shift may also be attained in planar structures composed of a multi-layered stack of metal and dielectric. In fact, negative index materials based on metal-dielectric multi-layers have been reported in literature [28]. A final observation that can be made in Fig. 4 regards the special case of $n = -1$; for a coaxial waveguide with a core diameter of 50 nm and a 70-nm wide Si channel a mode with $n = -1$ is observed with a FOM= 5 at $\omega = 2.61 \times 10^{15}$ rad/s (free-space wavelength of 720 nm).
Thus far we have studied the influence of the coax geometry on the frequency dispersion of \( k \). Next, we will investigate the effect of changing the type of metal in core and cladding, as well as the dielectric in the cylindrical channel. Figure 5 shows the frequency dispersion for a coaxial waveguide with inner metal core diameter of 75 nm and dielectric channel width of 25 nm surrounded by an infinite metal cladding. We compare the results for Si (blue curves), GaP (green curves), and silica (red curves) channels in Ag, and for a Si channel in Au (purple curves). The curves are normalized to the surface plasmon resonance frequency for the corresponding planar metal/dielectric geometry. Interestingly, coaxial plasmon waveguides support dominant negative index modes regardless of the investigated choice of materials. The propagation vector \( k' \) is most strongly negative for waveguides filled with GaP and least negative for silica, which indicates that, to obtain a strong effect, the dielectric constant needs to be high (\( n_{GaP} = 3.5 \) at the GaP/Ag surface plasmon resonance). The figure-of-merit for the modes in Fig. 5(a) is plotted in Fig. 5(b). Due to the low loss and high index of GaP, the highest figure-of-merit is found in these waveguides. The highest number we found (FOM = 18) was for a 10-nm-wide GaP channel in Ag at \( \omega = 4.1 \times 10^{15} \) rad/s (\( \lambda_0 = 460 \) nm, data not shown). Waveguides composed of Au show a lower FOM than those with Ag, which is attributed to the higher losses in Au.

Finally, in Fig. 6 we present the field distribution in a coaxial waveguide with negative index. Figure 6(a) shows the \( H_y \)-field on the outer metal-dielectric interface of a coaxial waveguide with 75-nm-diameter Ag core and 25-nm-wide GaP channel for a frequency \( \omega = 3.75 \times 10^{15} \)
rad/s (free-space wavelength of 500 nm, \( \omega / \omega_{SP} = 1.08 \) in Fig. 5). Clearly, the phase fronts in the waveguide are not planar. As a result, a non-zero \( z \)-component of the electromagnetic field is observed. Figure 6(b) shows the distribution of \( H_r \) in the transverse plane. Its magnitude is similar to that of the \( H_t \)-field. For completeness, Figs. 6(c) and 6(d) show the \( H_y \) and \( H_z \) components of the field. Note that these fields are antisymmetric with respect to the center of the dielectric channel and are located mostly inside the metal.

4. Conclusion

We have theoretically demonstrated that coaxial plasmon waveguides sustain modes with negative refractive index at optical frequencies. The negative-index modes have a larger propagation length than the positive-index modes over a large spectral range, depending on the dielectric thickness. For a 10-nm-wide GaP dielectric and a 75-nm-wide Ag core a figure-of-merit \( k'/k'' = 18 \) is found at \( \lambda_0 = 460 \text{ nm} \). For Ag/Si/Ag coaxial waveguides with increasing Si-channel thickness the dominant negative-index mode shifts well below the surface plasmon resonance frequency: for a 70 nm Si-channel it is found at \( \lambda_0 = 750 \text{ nm} \). The mode index can be fine-tuned to a value of -1 with a figure-of-merit as high as 5 at 720 nm. At slightly higher frequencies, the same mode has an effective index \( n=0 \) with positive group velocity, and a decay length of 500 nm. Overall higher tunability and figure-of-merit are found for coaxial waveguides of Ag rather than Au, and filled with a dielectric of highest optical constant. Based on the large degree of dispersion control that can be achieved with coaxial plasmon waveguides we anticipate that these structures will find use in new designs for nanoscale photonic integrated circuits (waveguides, splitters, multiplexers), in three-dimensional negative-index metamaterials, and invisibility cloaks.

Acknowledgments

We would like to thank J. A. Dionne, H. J. Lezec, E. Verhagen, and A. F. Koenderink for fruitful discussions. This work was supported by the Energy Frontier Research Center program of the Office of Science of the Department of Energy under grant DE-SC0001293, by the National Science Foundation under the Graduate Research Fellowship Program, and made use of facilities supported by the Center for Science and Engineering of Materials, an NSF Materials Research Science and Engineering Center at Caltech. This work is also part of the research program of the 'Stichting voor Fundamenteel Onderzoek der Materie (FOM)', which is financially supported by the 'Nederlandse Organisatie voor Wetenschappelijk Onderzoek (NWO)'. It was also supported by 'NanoNed', a nanotechnology program funded by the Dutch Ministry of Economic Affairs.